# Drug delivery neural probes

Applications in Neural Microsystems Lecture 9

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#### Outline

- 1. Goal of local drug delivery
- 2. Active drug delivery principles

A. Convection enhanced

**B.** Electrophoresis

- 3. Technology of passive devices
- 4. Integrated active solutions
- 5. Exampes of microelectrodes with integrated fluidics

## Applications

Microneedles:

- Transdermal injection of drugs
- Microdialysis tests

Microelectrodes:

- Administration of pharmacuticals through the blood-brain barrier (therapy, diagnostics)
- Injection of anti-inflammatory agents during implantation
- Injection of anatomic tracers
- Release of neurotransmitters to investigate neurodegenrative diseases

Basic configurations:

*Microfluidics* + *MEMS* = *Multipurpose implants* 

#### Transdermal delivery



Prausnitz, 2009

Specific delivery technologies:

- Passive
- Chemical enhancer

Applications already approved: Dementia (Rivastigmine, 2007) Rotigotine (Parkinson's disease, 2006) Selegiline (Depression, 2006)

Under clinical development: Influenza vaccine Sufentanil (chronic pain) Parathyroid hormone (Osteoporosis)

- Iontophoresis
- Heat enhancement

## Drug delivery through the blood brain barrier (BBB)

BBB: separates circulating blood from extracellular fluid in the CNS

- Nearly all neurotheraputics and small molecule drugs are excluded
- Nanoparticles embedded in liposomes & peptides are able to cross BBB
- Alternative diagnostics:
- Disruption of BBB by local injection of drugs



#### Junction between Endothelial cells



#### Cross section of blood vessel



#### Longitudinal section of blood vessel



#### Strategies to administer drugs in the brain

- Convection enhanced delivery
- Iontophoresis aided delivery
- Polymer coatings with tunable drug release



Usually pressure based solutions are available on the market.

## Convection enhanced delivery (CED)

Conventional solutions:

- Bulky (250-500 micron in diameter)

- Rigid (E ~200GPa)



Fundamentals in hydrodynamics

Governing equation (Navier-Stokes):

$$\rho \frac{\delta \boldsymbol{u}}{\delta t} = -\boldsymbol{\nabla} \boldsymbol{P} + \boldsymbol{\mu} \boldsymbol{\nabla}^2 \boldsymbol{u} + \mathbf{g}$$

Driving forces:

pressure gradient, viscous forces, gravity

#### Flow at the microscale in CED





#### Typical circuit models in microfluidics



Series: 
$$R_{total} = R_1 + R_2 + ... + R_N$$
  
Parallel:  $\frac{1}{R_{total}} = \frac{1}{R_1} + \frac{1}{R_2} + .... + \frac{1}{R_N}$ 

P - pressure, Q - flow rate,  $R_H - hydraulic$  resistance

#### Hydraulic resistance



- Cross-section dominantly influences
- Typically inherently limited by production technology used

#### Viscosity

#### Water viscosity



Shear rate: change of velocity at which one layer of fluid passes over an adjacent layer



#### Iontophoretic drug delivery (IDD)

- Administration of solutions containing charged particles
- Governing equations: Faraday's law



N<sub>e</sub> – mol number of electrons which pass through the external circuit per second,

- F Faraday constant (96487 C/mol)
- Q drug delivery rate
- $M_w$  molecular weight

## Integrated solutions (silicon)



Small volume of fluids

Large volume of fluids 14

## Integrated solutions (polymers)



#### Silicon electrodes







## Flexible microfluidic probes on polymers



## Out-of-plane Si structures with wafer bonding



#### Hollow microelectrodes in SU-8 double layer



#### Miniaturization of complete systems



Shin, 2015

"Micro meets macro": overall device dimensions are typically limited by external interfaces (tubing, connectors, pumps etc)

## Integration of passive components (mixing)



Shin, 2015

#### Integration of passive components (mixing)



#### Compact pumping solutions (thermal actuation)



Fong, 2015

## Requirements of pumping solutions

- Low power consumption
- Long term stability of drug release
- Fast response time
- Leak-free and clog free operation
- Small device footprint
- Multichannel actuation (administration of multiple drug components/reagents)



## Multipurpose silicon drug delivery probes

#### Table 3

Realized silicon microelectrodes and concepts providing simultaneous recording and drug delivery functionalities.

Reference	Basic fabrication process	Design			Bench-top tests			Overall performance			
		Fluidic outlet/ shaft	Probe length (mm)	Configuration	Actuation	Fluidic	Electrical	Mechanical	Flow rate (µL/min)	Pressure (kPa)	Test on simultaneous functions
[68]	Wet etching	1	6	Single-shaft	Ext. spyringe pump	Yes	Yes	-	10-90	2.5-300	-
[69]	Wet etching + fused silica catheter	1	-	Single-shaft	Ext. syringe pump	Yes	-	-	0.5–1	-	Acute in vivo
[5]	Dry etching + wafer bonding	1–3	6-8	Dual-shaft	Ext. syringe pump	Yes	Yes	Yes	0.75-3.75	0.5-2.5	-
[55]	Dry etching + Parylene sealing	2	2.8	3D array	Ext. syringe pump	Yes	Yes	-	2-10	2.7–16	-
[33]	Dry etching + wafer bonding	1–2	8	3D array	Ext. syringe pump	Yes	-	-	0.75-3.75	0.5-2.5	-
[20]	Dry etching + wafer bonding	1	8	Dual-shaft	Thermal actuator	-	-	-	0.75-3.75	0.5-2.5	Chronic in vivo
[21]	Dry etching + poly-Si sealing	1–2	15-70	Single-shaft	Ext. syringe pump	Yes	Yes	-	0.1-1.6	40-200	Acute in vivo

Fekete, 2015, Sensors & Actuators B:Chemical

"The more complicated, the more likely users will be not able to use"

## Multipurpose polymer drug delivery electrodes

#### Table 4

Flexible neural interfaces with integrated microfluidic functionality.

Auth	ors Interface type	Substrate materials	Channel dimensions (μm x μm)	Flow rate (µL/min)	Release rate (nmol/days)	In vivo animal model	In vitro study	Test duration	Extra features
[103 [107 [100 [10]	penetrating penetrating penetrating penetrating	Polyimide Parylene C Parylene C Polyimide/SU-8	up to 20× 200 up to 10× 200 11.4×50 50×45	up to 1200 N/A 0.09 240	- - -	- rat - mouse	yes - yes -	- acute 27 days acute	electrical recording electrical recording – electrical recording, waveguidesfor optogenetics
[44] [8] [20] [101	surface penetrating surface surface	Polyimide/PDMS SU-8 PDMS PDMS/Parylene/PET	50 × 200 40 × 20 50 × 100 10 × 10	- 40 120-360 5.2	0.1–0.5 - - -	– rat rat/mouse mouse	yes - -	– acute 6 weeks 6 weeks	electrical recording electrical recording electrical stimulation wireless, µLEDs for optogenetics

Fekete, 2017, Sensors & Actuators B:Chemical

#### "Thickness requirements limits the range of materials"

Polymer coatings for drug delivery

Solvent activated

(swelling- or osmotically-controlled devices)

• Chemically controlled

(biodegradable polymers)

- Externally-triggered systems (Temperature, pH)
- Electrically activated (conductive polymers)



## Case study 1

# Fabrication & characterization of silicon microelectrode for CED

#### Concept & design How to integrated drug delivery channels?



Probe designs	MFA	DBS Kit	Neuro Nexus	Neuro Probe
Length [mm]	70	> 100	70	8
Diameter [µm]	200 400	1270	Аррх 150	150- 250
Nr of the Pt electrical sites	4 - 16	4	32	4
Fluidic channel	+	-	-	+



#### Fabrication (Monolithic integration of fluidic channel in neural probes)

I. Fluidic channelII. Electrical wiringIII. Probe body



Process steps included:

- 4 photolithography steps
- Lift-off (platinum wiring & sites)
- Low-pressure chemical vapour deposition of dielectrics
- Deep reactive ion etching of channel & device contour



#### Dry etching - fundamentals



#### Why dry etching?

#### Dry etching advantages

- Eliminates handling of dangerous acids and solvents
- Uses small amounts of chemicals
- Isotropic or anisotropic/vertical etch profiles
- Directional etching without using the crystal orientation of Si
- Faithful pattern transfer into underlying layers (little feature size loss)
- High resolution and cleanliness
- Less undercutting
- Better process control

#### Dry etching disadvantages:

- Some gases are quite toxic and corrosive.
- Re-deposition of non-volatile compound on wafers.
- Expensive equipment (\$200-500K for R&D, few million for industrial tools).

#### Types of dry etching:

- Non-plasma based uses spontaneous reaction of appropriate reactive gas mixture.
- Plasma based uses radio frequency (RF) power to drive chemical reaction.

#### Bosch process (used to define channel depth and device contour)







#### Versatility of DRIE process

#### Two materials, four etching procedure, one machine

	SiO <sub>2</sub> etch	Deep Si etch—Bosch process (passivation/etch)	Highly anisotropic SiO <sub>2</sub> etch	Isotropic Si etch
Process step	Step 3	Step 4	Step 7	Step 8
Pressure (mTorr)	8	30/40	30	40
ICP power (W)	2,000	-/750	_	750
LF power (350 kHz)	_	1/8 W	_	8 W
RF power (W)	100	-	200	
C <sub>4</sub> F <sub>8</sub> flow rate (sccm)	36	100/-	_	
O2 flow rate (sccm)	4	-	_	
SF <sub>6</sub> flow rate (sccm)	_	-/150	_	150
Ar flow rate (sccm)	_	_	20	
CHF <sub>3</sub> flow rate (sccm)	-	-	30	
Time	_	4/9 s (cycle time)	5 min	5 min

#### Original process flow



#### Improved process flow



Fekete et al, 2012

Improved version: probe surface can be exploited to add further functional components

### Step coverage

• Tailors the quality of forming buried/embedded components in the substrate



Uniform Non-uniform Aspect ratio = x / y

Uniform: typically CVD; Non-uniform: typically PVD

- Chemical vapour deposition(CVD): PECVD, LPCVD, ALD
- Physical vapour deposition (PVD): evaporation, sputtering

## Modelling of step coverage (evaporation)



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#### Fabrication – Fluidic channel

Poly-crystalline silicon (polySi) is deposited inLPCVD chamber to fill up the trench

2

Si



MD = 29 mm

Before filled by LPCVD polySi

 Stage at Z = 33.028 mm
 Stage at T = 0.0\*
 Signal A = InLe

 Stage at M = 4.693 mm
 Titt Angle = 0.0\*
 Signal B = SE2

 Innace Pixel Size = 35.65 nm Titt Corrn. = Off
 Scan Rot = Off

HT = 5.00 kV

WD = 10.0 mm

Poly-Si

#### After filled by LPCVD polySi Mag = 3.50 K X mage Pixel Size = 101.9 nm HT = 5.00 KV WD = 1.6 mm Stage at T = 0.0 \* Stage at Z = Tit Angle = 54.0 \* Stage at M = Tit Corrn. = Off Aperture Size •

17 µm

# Effect of dry etching fabrication parameters on channel location and profile

Investigated relationships:

- Trench width vs. Deep Si etching
- Aspect ratio vs Si etch in SF<sub>6</sub> plasma
- Trench width vs profile assymetry





Fekete et al., 2013

## Chips ready for packaging



### Optical inspections





**Microchannels** 





#### Characterization – Electrical properties

Results of impedance spectroscopy



Final impedance values at 1 kHz: 517  $\pm$  43 k $\Omega$ .

Deep-brain probe after packaging

100 um

#### Hydrodynamic characterization (chip-scale)



*Setup:* Pumping DI water through the integrated drug delivery channel of a single chip.



Pressure vs flow rate

Hydrodynamic resistance is increasing with increasing fluidic channel length

Flow rate is in the range 0.5 - 1.5  $\mu l/min_{45}$ 

## Fracture mechanics



a400x400 ♦400x200 8,00 4,00 △200x200 O200x400 2,00 Fracture force [N] 1,00 0,50 0,25 0,13 ۶ 0.06 0,03 \*\*\*\*\*\*\*\*\*\*\*\* 0,02 0,01 0 2 6 8 4 Probe length [cm]

Role of second moment of inertia! Lower in case of a hollow structure than for solid structure of the same cross-section

Constraints:





#### Buckling analysis



Critical buckling force in Euler beam theory:

$$F_b = \frac{\pi^2 \cdot E \cdot I}{4 \cdot L^2}$$

I - second moment of area (depends on cross-section)



#### In vivo testing – External fluidic interface

tetrode (#4)

2 buried channels

• Number of integrated fluidic components:



http://www.precidip.com Preci Dip PCB socket connector

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## In vivo validation

Acute animal experiment demonstrated simultaneous drug injection and neural signal recording (LFP, MUA, SUA) Evoked activity after *Resting state before* injection injection ML: 3.2 mm Cortex man man man mannannum Cortex mannammana mannahanna Manuman manumment +256 µV 1 s 0.5-100 Hz A Hippocampus 0.5-100 Hz Thalamus Thalamus +512 µV[\_]s 0.5-100 Hz +512 µV 1 s 0.5-100 Hz C 0.5-100 Hz F +512 µV 1 s D

Evoked potentials by administration of biccuculine through the integrated channels

Pongrácz, 2013

# Case study 2

# Characterization of hollow silicon microelectrode for iontophoretic administration of pathway tracers

#### Motivation

- Bridging the gap between brain structure and function
- Mapping connectome in animal studies



Human Connectome Project





S. W. Oh et al., Nature 508, pp. 207-214, 2014.

#### Goal

<u>Validation</u> of a combined tool for in vivo electrophysiology and neuronal labeling through iontophoretic tracer injection

#### Connectome

#### Anatomical connectivity vs functional connectivity



Connectome can be "rewired"



neuroplasticity

## Neuronal labeling



## Iontophoretic tracer injection



Iontophoretic drug delivery

• Governing equations: Faraday's law



 $N_{e}$ 

# Labeling protocol

#### **Procedure:**

- 1. Channel filling with BDA.
- 2. Implantation
- 3. Pt electrode negatively biased Silver electrode positively biased
- 4. Current injection (15 mins)
- 5. Electrophisiology (where applicable)
- 6. Histology



Targeted region: somatosensory cortex
Substance: 10% mixture of high & low MW BDA dissolved in 0.01M PBS (pH 7.4)
Survival time: 7 days
Histology: standard ABC protocol to visualize BDA in coronal vibratome sections

Additional control experiment: without any voltage bias

Challenge: probe dimension should be reduced to increase survivial rate of labelled neurons

#### Change in probe technology for limited tissue damage?

Thinning the probe with etching-before-grinding technology



## Grinding is compatible with the fab process?



## Labeled neuronal cells



Effective cross section of labeling: ~ 200-300 micron

#### Control experiment



a. Labeled neuronal cell bodies ( $I_{inj} = 4 \mu A$ , ON/OFF cycle = 7 s /7 s)

b. Control experiment(without injection current)

Conclusion: diffusion through pre-loaded channels compared to IDD is negligible

#### Connectome labeling

Iontophoretic injection (I = 4  $\mu$ A, ON/OFF cycle = 5/5 s) & Electrophysiology



Green arrow: ipsilateral, red arrow: contralateral, blue arrow: thalamic connections.

#### Connectome labeling



## Electrophysiology

#### In vivo extracellular recording after tracer injection in anaesthetized rats



Neuronal activity recorded with a linear MEA after injection

Detected unit activities at the location of iontophoresis (A) and 800  $\mu$ m above (B).

## Questions

- 1. List five medical applications of microscale drug delivery.
- 2. What parameters determines the flow rate in the case of iontophoretic injection of charged particles?
- 3. What parameters determine hydrodynamic resistance in a microchannel?
- 4. Draw the schematic process flow of surface-, bulk micromachining approaches to fabricate microfluidic channels.
- 5. What is the relationship between pressure and flow rate in a laminar flow?
- 6. What dimensional and material parameters determine the buckling force of a hollow needle?
- 7. How does the steepness of pressure flow rate curve changes if the length of the microchannel increased?
- 8. What is the operation principle of thermally actuated integrated micropump?
- 9. What is the effect of elastic components on flow profile?